

Notice of References Cited	Application/Control No. 10/622,413	Applicant(s)/Patent Under Reexamination MEIJER ET AL.	
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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-20040143827 A1	07-2004	de Jong	717/106
*	B	US-20040143820 A1	07-2004	de Jong	717/166
*	C	US-6981250	12-2005	Wiltamuth et al.	717/120
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
	O					
	P					
	Q					
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NON-PATENT DOCUMENTS

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